

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of )  
Satoshi SHIBATA et al. )  
Based On Application No. 09/984,908 ) Art Unit: 2859  
Which Was Filed: October 31, 2001 ) Examiner: Pruchnic  
For: METHOD FOR PREDICTING TEMPERATURE, )  
TEST WAFER FOR USE IN TEMPERATURE )  
PREDICTION, AND METHOD FOR EVALUATING )  
LAMP HEATING SYSTEM ) Date: June 23, 2003

REQUEST FOR DRAWING CHANGE APPROVAL

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached hereto is a copy of Figure 11 with the requested drawing changes shown in red. It is respectfully requested these changes be reviewed and approved by the Examiner prior to the issuance of the subject application.

Respectfully submitted,

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DRAWING  
CHANGES  
APPROVED  
- Joe  
3/2/04